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APPLICANTS

Takeshi Nogami, Kanagawa, JAPAN;

Akira Yoshio, Tokyo, JAPAN;
Shuzo Sato, Kanagawa, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/655,833 09/06/2000 PAT 6,693,036 *ok HWT*

** FOREIGN APPLICATIONS *****

JAPAN P11-253605 09/07/1999 *ok HWT*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/21/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 25	TOTAL CLAIMS 30	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowances				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>[Initials]</i>		

ADDRESS

23353
 RADER FISHMAN & GRAUER PLLC
 LION BUILDING
 1233 20TH STREET N.W., SUITE 501
 WASHINGTON, DC
 20036

TITLE

Method for producing semiconductor device, polishing apparatus, and polishing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
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